

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L2	5	(silicon adj oxide) and silica and dielectric and buffer and SOG and laser	USPAT	OR	OFF	2005/01/31 17:02
L3	0	(silicon adj oxide) and silica and dielectric and buffer and SOG and (ELA or SLS)	USPAT	OR	OFF	2005/01/31 17:08
L4	1	(ELA) and (porous adj silica) and sol-gel	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/31 17:11
S1	1	("5733641").PN.	USPAT	OR	OFF	2005/01/26 15:22
S2	575	(438/758).CCLS.	USPAT	OR	OFF	2005/01/26 15:23
S3	5	S2 and (porous adj silica)	USPAT	OR	OFF	2005/01/26 15:24
S4	5	S2 and (porous adj silica) and dielectric	USPAT	OR	OFF	2005/01/26 17:04
S5	17	(silicon adj oxide) and ethanol and (TEOS or TMOS) and (porous adj silica) and dielectric	USPAT	OR	OFF	2005/01/26 15:25
S6	2	(silicon adj oxide) and ethanol and (TEOS or TMOS) and (porous adj silica) and dielectric and laser	USPAT	OR	OFF	2005/01/26 16:35
S7	0	ethanol and (TEOS or TMOS) and (porous adj silica) and dielectric and laser and (grain with size)	USPAT	OR	OFF	2005/01/26 16:37
S8	1	ethanol and (TEOS or TMOS) and (porous adj silica) and dielectric and laser and (grain with size)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/26 16:37
S9	2	(TEOS or TMOS) and (porous adj silica) and dielectric and laser and (grain with size)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/26 16:38
S10	1	(porous adj silica) and (buffer adj dielectric) and laser and grain and gel	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/26 16:39

S11	1	(SLS or ELA) and (porous adj silica) and sol-gel	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/26 16:40
S13	6	(ELA) and (porous adj silica)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/26 16:45
S14	92	(porous adj silica) and semiconductor and ammonia and TEOS	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/26 16:46
S15	87	(porous adj silica) and semiconductor and ammonia and TEOS and dielectric	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/26 16:46
S16	4	(porous adj silica) and semiconductor and ammonia and TEOS and dielectric and grain	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/26 16:46
S17	0	(silicon adj oxide) and (buffer adj dielectric) and silica	USPAT	OR	OFF	2005/01/26 17:06
S18	7956	(silicon adj oxide) and silica	USPAT	OR	OFF	2005/01/26 17:06
S19	2425	(silicon adj oxide) and silica and dielectric	USPAT	OR	OFF	2005/01/26 17:06
S20	318	(silicon adj oxide) and silica and dielectric and buffer	USPAT	OR	OFF	2005/01/26 17:06
S21	15	(silicon adj oxide) and silica and dielectric and buffer and SOG	USPAT	OR	OFF	2005/01/31 17:08